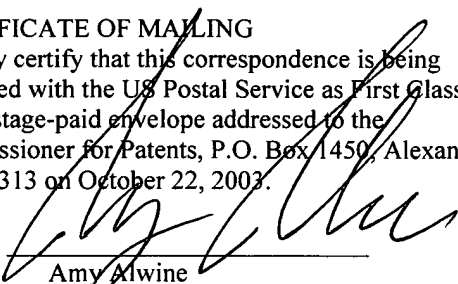




IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

<p>In re application of:</p> <p>TALIEH et al.</p> <p>Serial No.: 09/941,360</p> <p>Filed: August 28, 2001</p> <p>Title: Method And Apparatus For Plating and Polishing A Semiconductor Substrate</p>	<p>RECEIVED OCT 31 2003 TC 1700</p> <p>Group Art Unit: 1742 Examiner: D. Valentine Docket: NT-004D-US</p> <p>CERTIFICATE OF MAILING I hereby certify that this correspondence is being deposited with the US Postal Service as First Class Mail in a postage-paid envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313 on October 22, 2003.</p> <p>Signed:  Amy Alwine</p>
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AMENDMENT A

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313

Dear Sir:

In response to the Office Action mailed July 2, 2003, Applicants petition for a one-month extension to the shortened statutory period response and asserts small entity status in an accompanying paper. A PTO-2038 form for \$55 is included to cover the one-month extension fee. Applicants request entry and consideration of the following Remarks and Amendment. Please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 5 of this paper.